

PATENT

ROT-2
#15
Maw
9/14/03

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Kim et al.

Serial No.: 10/032,687

Filed: December 28, 2001

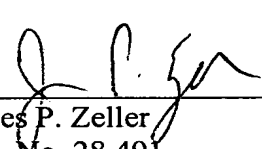
For: METHOD OF FORMING
WIRING IN SEMICONDUCTOR
DEVICES

Group Art Unit: 2822

Examiner: Maria F. Guerrero

I hereby certify that this paper is being
deposited with the United States Postal
Service, first class postage prepaid, addressed
to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450

August 29, 2003


James P. Zeller
Reg. No. 28,491

PETITION UNDER 37 C.F.R. §1.136(a)

Commissioner for Patents
Washington, DC 20231

Sir:

Applicants, by their attorneys, petition for a two-month extension of time to file a
response to the official action of April 3, 2003.


Submitted herewith is the patent application processing fee of \$410.00.

Any additional required fee may be charged or any overpayment credited, to our
Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

By:


James P. Zeller
Reg. No. 28,491
Attorneys for Applicants

July 29, 2003

6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606-6357
(312) 474-6300

09/03/2003 MAHMED1 00000089-10032687
No id date 09/03/2003 MAHMED1
09/03/2003 MAHMED1 00000089 -10032687 OF
02 FC:1252 410.00 OP

09/03/2003 MAHMED1 00000090 10032687

02 FC:1252

410.00 OP

RECEIVED
SEP-4 2003
TECHNOLOGY CENTER 2800